

INTERNATIONAL  
GEMOLOGICAL  
INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

November 18, 2024

IGI Report Number

Description

Shape and Cutting Style

Measurements

LG660443503

LABORATORY GROWN DIAMOND

EMERALD CUT

7.09 X 4.76 X 3.00 MM

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

1.00 CARAT

G

VVS 2

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

Fluorescence


VERY GOOD

VERY GOOD

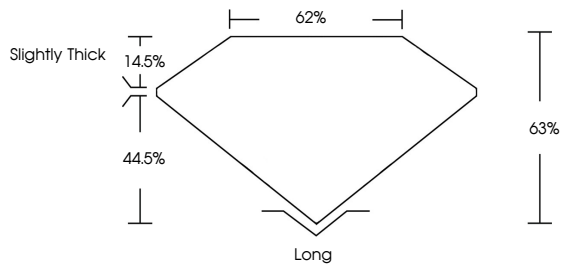
NONE

Inscription(s)

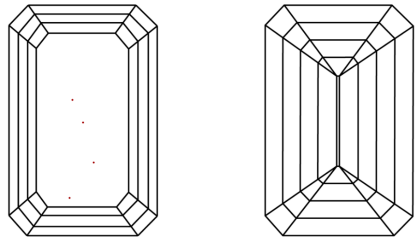
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

 LG660443503

PROPORTIONS

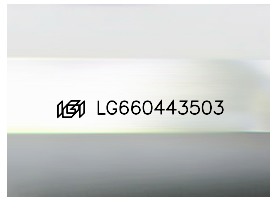


CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.



Sample Image Used

COLOR



D E F G H I J

Faint Very Light Light

CLARITY

IF VS <sup>1-2</sup> VS <sup>1-2</sup> SI <sup>1-2</sup> I <sup>1-3</sup>


Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included



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
VERY GOOD

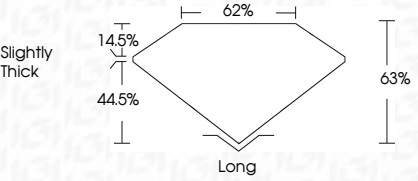
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IGI

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EMERALD CUT

7.09 X 4.76 X 3.00 MM

Carat Weight

Color Grade

Clarity Grade

Depth

Girdle

Slightly Thick

Culet


Long

Polish

Symmetry

Fluorescence

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